



BOX AFTER FINAL
EXPEDITED PROCEDURE

740756-1996

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Shunpei YAMAZAKI et al.

Application No.: 09/352,362

Filed: July 13, 1999

For: CRYSTALLINE SEMICONDUCTOR THIN FILM)
METHOD OF FABRICATING THE SAME,
SEMICONDUCTOR DEVICE, AND METHOD
OF FABRICATING THE SAME

Art Unit: 2815

Examiner: Jose R. DIAZ
CERTIFICATE OF MAILING

I hereby certify that this
correspondence is being deposited with
the United States Postal Service with
sufficient postage as First Class Mail in
an envelope addressed to: Assistant
Commissioner for Patents, Washington,
D.C. 20231, on 12-12-01

INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents
Washington, D.C. 20231

December 12, 2001

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application. A copy of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a). Also attached is a check in the amount of \$180.00 for the statutory disclosure fee.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380.

12/20/2001 BNGUYEN1 00000028 09352362

02 FC:126

180.00 OP

Respectfully submitted,

NIXON PEABODY, LLP

By

Luan C. Do

Reg. No. 38,434

EJR/LCD/sbs

8180 GREENSBORO DRIVE, SUITE 800
McLean, Virginia 22102
Telephone: (703) 790-9110
Facsimile: (703) 883-0370